

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q85660

Heiji WATANABE, et al.

Appln. No.: 10/521,311

Confirmation No.: 1690

Group Art Unit: 2815

Filed: January 14, 2005

Examiner: WARREN, MATTHEW E

For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND  
MANUFACTURING APPARATUS OF THE SAME

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment dated August 7, 2008, please  
enter and consider the following.

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